

PATENT
97-CT-174

RECEIVED
AUG - 7 2002
TECHNOLOGY CENTER 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
RAFFAELE ZAMBRANO)
Serial No.: 09/191,743)
Filed: November 13, 1998)
For: IN-SITU DEPOSITION AND)
DOPING PROCESS FOR POLY-)
CRYSTALLINE SILICON LAYERS)
AND THE RESULTING DEVICE)

Group Art Unit: 2823

Examiner: M. Estrada

COPY OF PAPERS
ORIGINALLY FILED

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
Washington, D.C. 20231

Sir:

In accordance with Rule 1.136, Applicant respectfully petitions the Commissioner for an extension of time extending to June 28, 2002, the period for response to the Office Action dated December 28, 2001. Please charge the amount of \$920.00 for the extension fee to Deposit Account No. 50-1556. The responsive paper is attached.

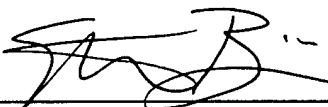
If it should be determined that a longer extension is required to prevent this application from becoming abandoned, or for any other reason an insufficient fee has been paid, please charge any insufficiency to Deposit Account No. 50-1556.

07/09/2002 TTRAM1 00000014 09191743

01 FE:179 740.00 CH
02 FE:117 920.00 CH

Respectfully submitted,

Date: June 28, 2002

By: 
Stephen Bongini
Registration No. 40,917

FLEIT, KAIN, GIBBONS,
GUTMAN & BONGINI P.L.
One Boca Commerce Center
551 Northwest 77th Street, Suite 111
Boca Raton, Florida 33487
Telephone: (561) 989-9811

TC 2800 MAIL ROOM

RECEIVED
JUL 18 2002

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: COMMISSIONER FOR PATENTS, WASHINGTON, D. C. 20231


Name of Person Mailing Paper


Signature of Person Mailing Paper

6/28/02
Date of Deposit